

JPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

: **Confirmation No. 9620**

Masanobu NOGOME et al.

: Docket No. 2003\_1075A

Serial No. 10/630,900

: Group Art Unit 2818

Filed July 31, 2003

: Examiner Mai Huong Tran

SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREOF

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action dated March 22, 2005, please amend the  
above-identified application as follows.

**AMENDMENT TO THE TITLE**

*Please replace the original title with following rewritten title.*

“Semiconductor Device Including a Photosensitive Resin Covering at Least a Portion of a Substrate Having a Via Hole”